

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*Fan-Ching Chien*  
Shean-Jen CHEN, Chun-Yu LIN, Fan-Ching CHIEN, K. T. HUANG, W. P. HU,

Applicant(s) : Wen-Yih CHEN, Kuan-Ching LEE and Wen-Hsien LI

Date :

Serial No. :

Group Art Unit:

Filed :

For : SURFACE PLASMON RESONANCE SENSOR WITH HIGH SENSITIVITY

Honorable Commissioner of Patents

and Trademarks

Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a completed Form PTO-1449 and copies of the pertinent parts of the references cited thereon. Comments on any non-English-language references (if any) pursuant to Rule are submitted herewith.

Respectfully submitted

Applicants(s): *[Signature]* *Chun-Yu Lin* *Fan-Ching Chien*

*K.T. Huang* *Wen Pm Hu* *[Signature]*

*Kuan-Ching Lee Wen-Hsien*

Encl: PTO-1449 & References

FORM PTO-1449 (Substitute)				ATTY. DOCKET NO. <u>03/96-UPS</u>		SERIAL NO.	
LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Shean-Jen CHEN et al.			
				FILING DATE		GROUP	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,991,488	11/23/1999	Slamon et al.	385	129	11/7/1997
	AB	6,242,264	6/5/2001	Natan et al.	436	171	1/12/2000
	AC						
	AD						
	AE						
	AF						
	AG						
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FOREIGN PATENT DOCUMENTS							
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OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							